Page 2

Listing of Claims:

1. (Previously Presented) A semiconductor device comprising: a plurality of unit cells connected in parallel, the unit cells each having a gate finger, wherein a pitch between the gate fingers is varied in a predetermined pattern between the gate fingers so as to provide a non-uniform pitch between the gate fingers,

wherein the predetermined pattern of non-uniform pitch between the gate fingers provides a substantially uniform junction temperature to a substantial majority of the gate fingers during RF operation.

- 2. Canceled.
- 3. Canceled.
- 4. (Original) The semiconductor device of Claim 1, wherein the predetermined pattern of non-uniform pitch between the gate fingers provides a substantially uniform junction temperature to all but the outermost gate fingers of the device when in operation.
- 5. (Original) The semiconductor device of Claim 1, wherein the unit cells comprise a plurality of unit cells arranged in a linear array.
- 6. (Original) The semiconductor device of Claim 1, wherein the unit cells comprise a plurality of unit cells arrange in a two dimensional array and wherein the non-uniform pitch gate fingers are provided in at least one of the two dimensions of the two dimensional array.
- 7. (Original) The semiconductor device of Claim 6, wherein the non-uniform pitch gate fingers are provided in both dimensions of the two dimensions of the two dimensional array.

Page 3

8. (Previously presented) The semiconductor device of Claim 1, wherein the pitch between the gate fingers varies in a substantially linear pattern from a small pitch to a larger pitch toward the center of the device.

9. Canceled.

- 10. (Original) The semiconductor device of Claim 1, wherein the unit cells comprise MESFET unit cells.
- 11. (Original) The semiconductor device of Claim 1, wherein the unit cells comprise silicon carbide semiconductor device unit cells or gallium nitride semiconductor device unit cells.
- 12. (Original) The semiconductor device of Claim 1, wherein the predetermined pattern of non-uniform pitch between the gate fingers provides a more uniform junction temperature than a corresponding uniform gate pitch device for a particular set of operating conditions.
- 13. (Original) The semiconductor device of Claim 2, wherein the junction temperature does not differ by more than about 5 °C over at least 80% of the plurality of unit cells.
- 14. (Original) The semiconductor device of Claim 2, wherein the junction temperature does not differ by more than about 5 °C over at least 95% of the plurality of unit cells.
 - 15. (Previously Presented) A field effect transistor, comprising:
- a plurality of unit cells electrically connected in parallel, each unit cell having a source region and a drain region; and
- a plurality of gates of the unit cells, the plurality of gates being electrically connected in parallel and having a non-uniform spacing between the gates, wherein

Page 4

the non-uniform spacing between the gates is provided in a pattern that provides a lower peak junction temperature during RF operation than a corresponding uniform gate pitch device for a particular set of operating conditions.

- 16. (Original) The field effect transistor of Claim 15, wherein the plurality of unit cells comprise a linear array of unit cells.
- 17. (Original) The field effect transistor of Claim 15, wherein the plurality of unit cells comprise a two dimensional array of unit cells.
- 18. (Original) The field effect transistor of Claim 17, wherein the non-uniform spacing of the gates is in a single dimension of the two dimensional array.
- 19. (Original) The field effect transistor of Claim 17, wherein the non-uniform spacing of the gates is in both dimensions of the two dimensional array.
- 20. (Original) The field effect transistor of Claim 15, wherein the plurality of unit cells comprise a plurality of silicon carbide unit cells.

21-27. Canceled.

- 28. (Previously presented) The field effect transistor of Člaim 15, wherein the spacing between the gates is at least $60 \mu m$, and wherein the field effect transistor is capable of producing at least 30 W of RF output power.
- 29. (Previously presented) The field effect transistor of Claim 15, wherein the spacing between the gates is at least 40 μ m, and wherein the field effect transistor is capable of producing at least 60 W of RF output power.

Page 5

30. (Previously presented) The field effect transistor of Claim 15, wherein the spacing between the gates varies in a substantially linear pattern from a small pitch to a larger pitch toward the center of the device.